

PATENT ABSTRACTS OF JAPAN

(11)Publication number : 09-017850

(43)Date of publication of application : 17.01.1997

(51)Int.Cl.

H01L 21/68

B23Q 3/15

C23C 16/44

H01L 21/205

H01L 21/3065

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(54) PLASMA TREATMENT DEVICE

(57)Abstract:

PURPOSE: To improve a durable period of an electrostatic chuck sheet and enable plasma treatment of a stable treatment body by restraining misregistration of a heat transfer gas blow out hole formed in an electrostatic chuck sheet.

CONSTITUTION: After an electrostatic chuck sheet 15 is applied to an upper surface of a lower electrode 3, a heat transmitting gas blow out hole is formed in the electrostatic chuck sheet 15 fitting to a position of a heat transfer gas supply hole 19 formed in the lower electrode 3 by using a vertical needle 40, etc.

